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AMENDMENTS TO THE CLAIMS

1. (Currently Amended) A method of producing a piezoelectric ceramic thick film on a substrate, said method comprising:

- providing a piezoelectric ceramic material in powder form;
- forming a liquid mixture by mixing the powdered material with a liquid phase precursor of a metal oxide of low-melting having a melting point lower than a temperature required for densifying the piezoelectric ceramic thick film by sintering, said precursor being adapted to decompose, upon subsequent annealing, into the metal oxide;
 - drying the liquid mixture to form a precipitate;
 - milling the precipitate to form a powdered precipitate;
 - adding an organic carrier to the powdered precipitate;
 - further milling the precipitate to form a paste;
 - depositing a layer of the paste, as a wet film, onto the substrate; and
- annealing the layered substrate at a temperature and for a time sufficient to cause transformation of the paste into the thick film.
- 2. (Original) A method according to claim 1, wherein the piezoelectric ceramic material is an inorganic ceramic material which exhibits the piezoelectric effect.

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3. (Original) A method according to claim 2, wherein the piezoelectric ceramic

material is lead zirconate titanate (PZT).

4. (Currently Amended) A method according to claim 1, wherein the metal oxide is

adapted to form a glass phase upon annealing at elevated a temperature between 800° and

<u>1000°C</u>.

5. (Original) A method according to claim 4, where in the metal oxide is selected

from one or more of Li₂O, Bi₂O₃ and PbO.

6. (Original) A method according to claim 5, wherein the liquid phase precursor is a

combination of the liquid phase precursors of Li₂O and Bi₂O₃.

7. (Previously Presented) A method according to claim 5, wherein the liquid phase

precursor of Li₂O is lithium ethoxide dissolved in ethanol.

8. (Previously Presented) A method according to claim 5, wherein the liquid phase

precursor of Bi₂O₃ is bismuth nitrate dissolved in acetic acid.

9. (Previously Presented) A method according to claim 6, wherein the liquid phase

precursors of Li₂O and Bi₂O₃ are mixed to form a Li-Bi acetic acid solution.

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10. (Original) A method according to claim 5, wherein the metal oxide is PbO and the

liquid phase precursor is a solution of lead acetate.

11. (Previously Presented) A method according to claim 1, wherein the powdered

piezoelectric material is in the form of a suspension in ethanol.

12. (Original) A method according to claim 11, wherein the powdered piezoelectric

material is fine-grained having an average grain size of below about 1.0µm.

13. (Original) A method according to claim 12, wherein the average grain size is

about 0.5 µm.

14. (Previously Presented) A method according to claim 1, wherein the total amount

of the metal oxide in the thick film is between about 1% and 5%, by weight.

15. (Original) A method according to claim 11, wherein the suspension is mixed with

the Li-Bi acetic acid solution, or the lead acetate solution, to form a liquid mixture.

16. (Currently Amended) A method according to claim 15, wherein the liquid mixture

is dried at an elevated a temperature between 75° and 150°C to form a dried precipitate.

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17. (Original) A method according to claim 16, wherein the liquid mixture is dried at

a temperature between about 75°C and 105°C for up to 10 hours.

18. (Cancelled)

19. (Currently Amended) A method according to claim 18 claim 1, wherein the

powdered precipitate is formed by milling the dried precipitate with a ball mill.

20. (Cancelled)

21. (Currently Amended) A method according to claim 20 claim 1, wherein the

organic carrier is selected from one or more of ethyl cellulose, terpineol, and ESL 400 an

organic binder containing texanol.

22. (Currently Amended) A method according to claim 21, wherein the organic

carrier is ESL 400-the organic binder containing texanol.

23. (Cancelled)

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24. (Currently Amended) A method according to claim 23 claim 1, wherein the paste

is deposited onto a surface of the substrate, by a printing process, as a as the wet film.

25. (Original) A method according to claim 24, wherein the printing process is a

screen printing process.

26. (Currently Amended) A method according to claim 1, wherein, prior to annealing,

the layered substrate including the deposited wet film is dried.

27. (Previously Presented) A method according to claim 1, wherein, prior to

annealing, an isostatic pressure is applied to the film.

28. (Currently Amended) A method according to claim 26, wherein the drying

temperature of the layered substrate including the deposited wet film is between about 20°C

and about 175°C.

29. (Currently Amended) A method according to claim 1 wherein the layered

substrate is annealed at a temperature of between about 800°C and about 1000°C 820°C and

about 950°C.

30. (Original) A method according to claim 29, wherein the annealing is conducted

for between about 10 minutes and about 4 hours.

31. (Previously Presented) A method according to claim 1, wherein the substrate is

formed of silicon.

32. (Previously Presented) A method according to claim 1, wherein the surface of the

substrate has a coating of platinum and the paste is deposited on this platinum coating.

33. (Previously Presented) A method according to claim 1, wherein a metal electrode

is formed on the piezoelectric ceramic thick film.

34. (Original) A method according to claim 33, wherein the metal is silver and the

electrode material is deposited on the film by a screen printing process.

35-38. (Cancelled)